

Photon beam generation at *PERLE*

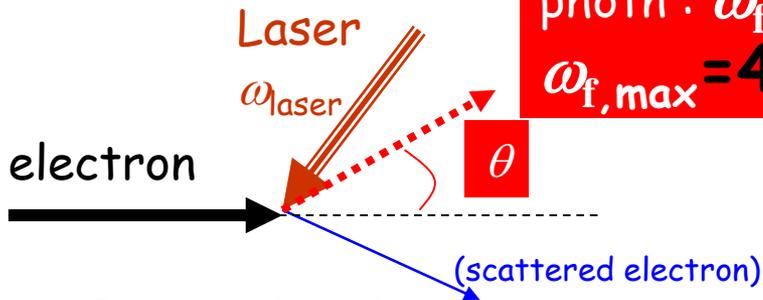
Outline

- Introduction on Compton scattering
 - Expectations for the ERL facility
- Optical/laser system for high average laser power

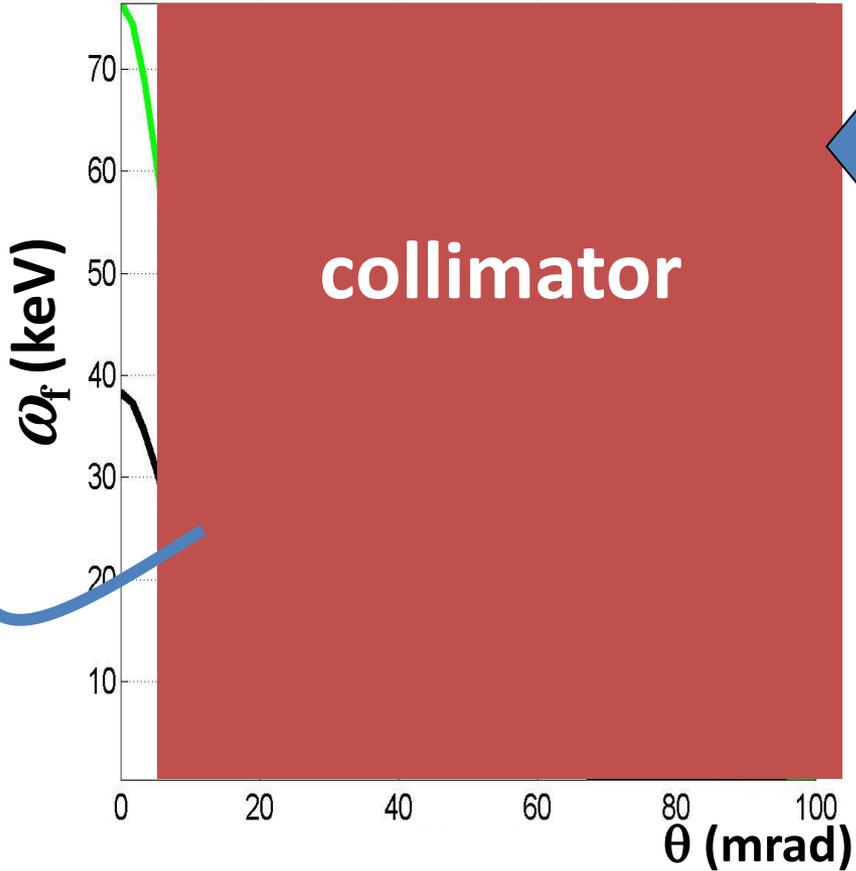
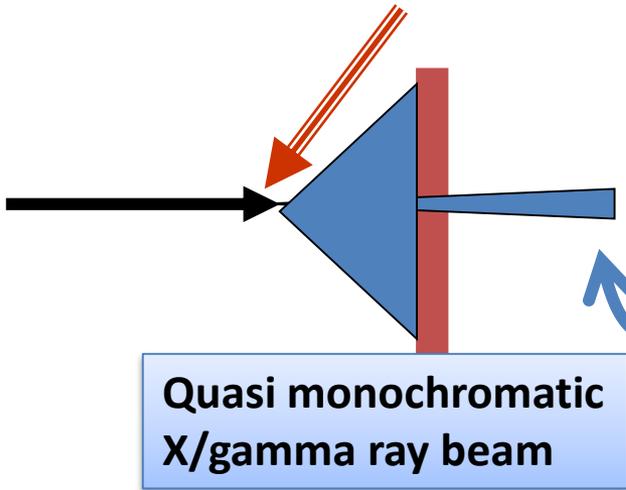
Compton scattering applications

photon: ω_f
 $\omega_{f,max} = 4\gamma^2 \omega_{laser}$

Compton scattering
 Photon_laser + e \rightarrow photon + e'
 is a
 2 body process $\rightarrow \omega_f = f(\theta)$

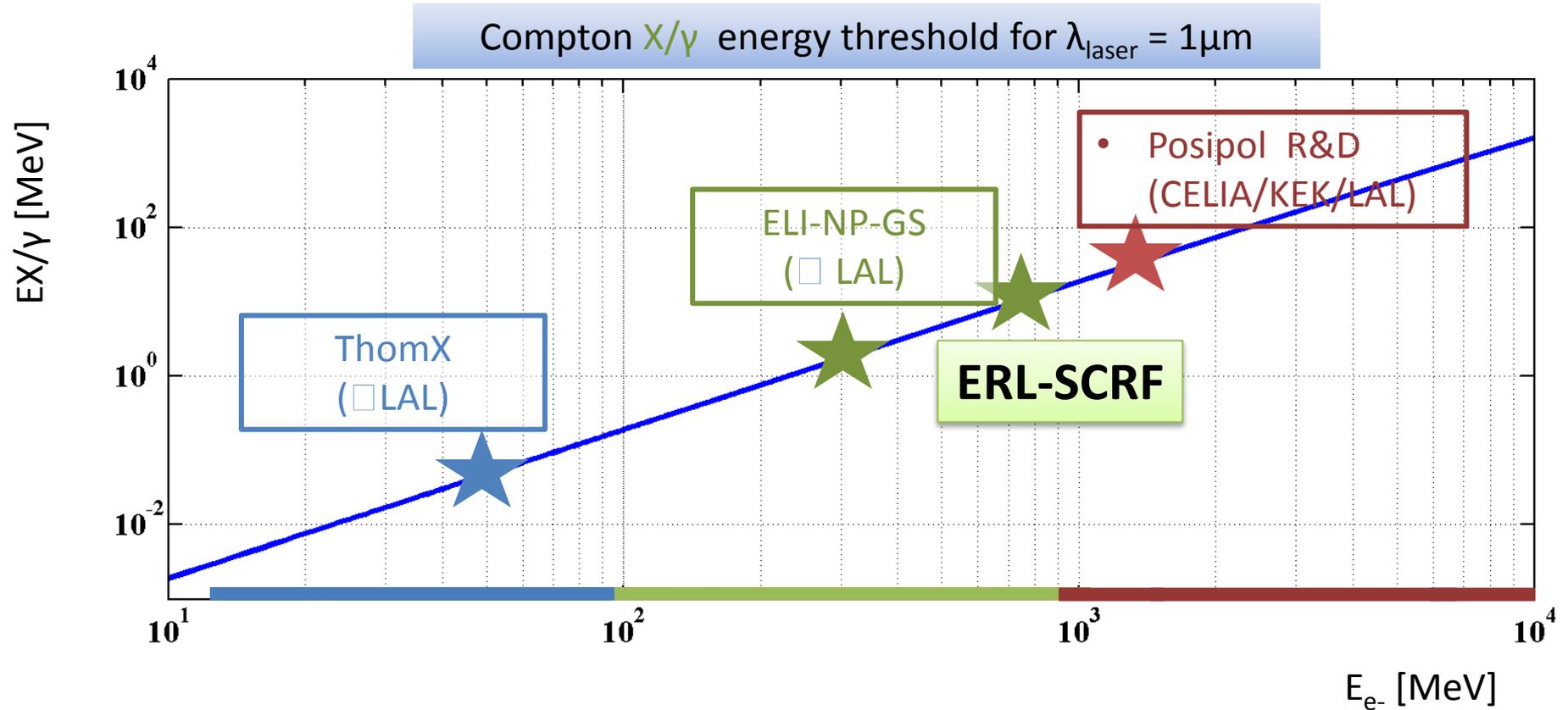


$\gamma = E_{electron} / m_e c^2$
 PRL138(1965)B1546



Quasi monochromatic X/gamma ray beam

Applications of Compton scattering: $e^- + h\nu \rightarrow e^- + X/\gamma$



~10-1MeV

Low energy applications

Radiography & Radiotherapy
Museology

...

~1MeV-100MeV

Nuclear fluorescence

Nuclear physics
Nuclear survey
Nuclear waste management

...

>100MeV

High energy applications

Compton polarimeter
 $\gamma\gamma$ collider
Polarised positron source

...

Photon beam properties

Total Scattered Photons

$$N_{\gamma} = 2.1 \cdot 10^8 \frac{U_L [J] Q [pC] f_{RF} n_{RF}}{h\nu [eV] \sigma_x^2 [\mu m] \sqrt{1 + (c\sigma_t \phi / \sigma_x)^2}}$$

scattered – photons/sec over 4π and total spectrum

f_{RF} = RF rep rate

n_{RF} = #bunches per RF pulse

U_L = Laser pulse energy

Q = electron bunch charge

$h\nu$ = laser photon energy [eV]

σ_x = electron bunch spot size at collision point

ϕ = collision angle ($\ll 1$)

$\phi = 0$ for head-on collision

σ_t = laser pulse length

***N.B.* all sigma's and angles are intended as rms,**

all distributions are assumed as gaussians in (phase) space and time

Energy-angular Spectral distribution

$$N_{\gamma}^{bw} = 1.2 \cdot 10^9 \frac{U_L [J] Q [pC] f_{RF} n_{RF}}{h\nu [eV] \sigma_x^2 [\mu m] \sqrt{1 + (c\sigma_t \phi / \sigma_x)^2}} \Psi^2$$

scattered – photons / sec within $\Psi \equiv \gamma \vartheta$

and within rms bandwidth $\Delta \nu_{\gamma} / \nu_{\gamma}$

Tomassini APB80(2005)419

$$\text{Spectral Density } [\# \text{ photons / s} \cdot \text{eV}] \text{ SPD} \equiv \frac{N_{\gamma}^{bw}}{\sqrt{2\pi} h \Delta \nu_{\gamma}}$$

RMS bandwidth, due to collection angle, laser phase space distribution and electron beam phase space distribution

$$\frac{\Delta v_\gamma}{v_\gamma} \cong \sqrt{(\gamma\mathcal{G})^4 + 4\left(\frac{\Delta\gamma}{\gamma}\right)^2 + \left(\frac{\varepsilon_n}{\sigma_x}\right)^4 + \left(\frac{\Delta v}{v}\right)^2 + \left(\frac{M^2\lambda_L}{2\pi w_0}\right)^4 + \left(\frac{a_{0p}^2/3}{1+a_{0p}^2/2}\right)^2}$$

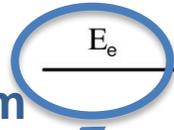
$\Psi = \gamma\mathcal{G}$ *normalized rms collection angle*

electron beam

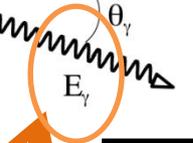
laser

Gamma beams at the ERL Facility

Incident electron beam



Incident laser beam



ELECTRON BEAM PARAMETERS

| | |
|------------------------|------------------|
| Energy | 900 MeV |
| Charge | 320 pC |
| Bunch Spacing | 25 ns |
| Spot size | 30 μm |
| Norm. Trans. Emittance | 5 μm |
| Energy Spread | 0.1 % |

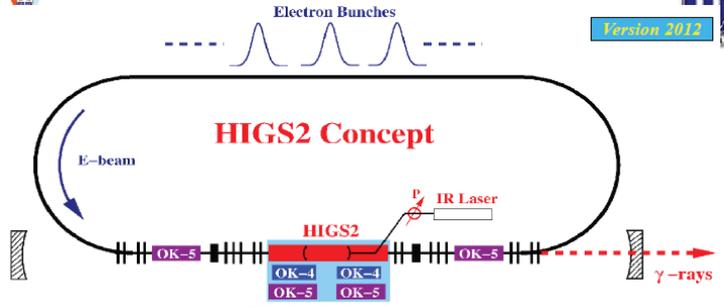
LASER BEAM PARAMETERS

| | |
|---------------|--|
| Wavelength | 515 nm - 1030 nm |
| Average Power | 300kW - 600 kW (can be increased R&D) |
| Pulse length | 3 ps (can be reduced) |
| Pulse energy | 7.5mJ - 15 mJ |
| Spot size | 30 μm (can be reduced) |
| Bandwidth | 0.02 % |

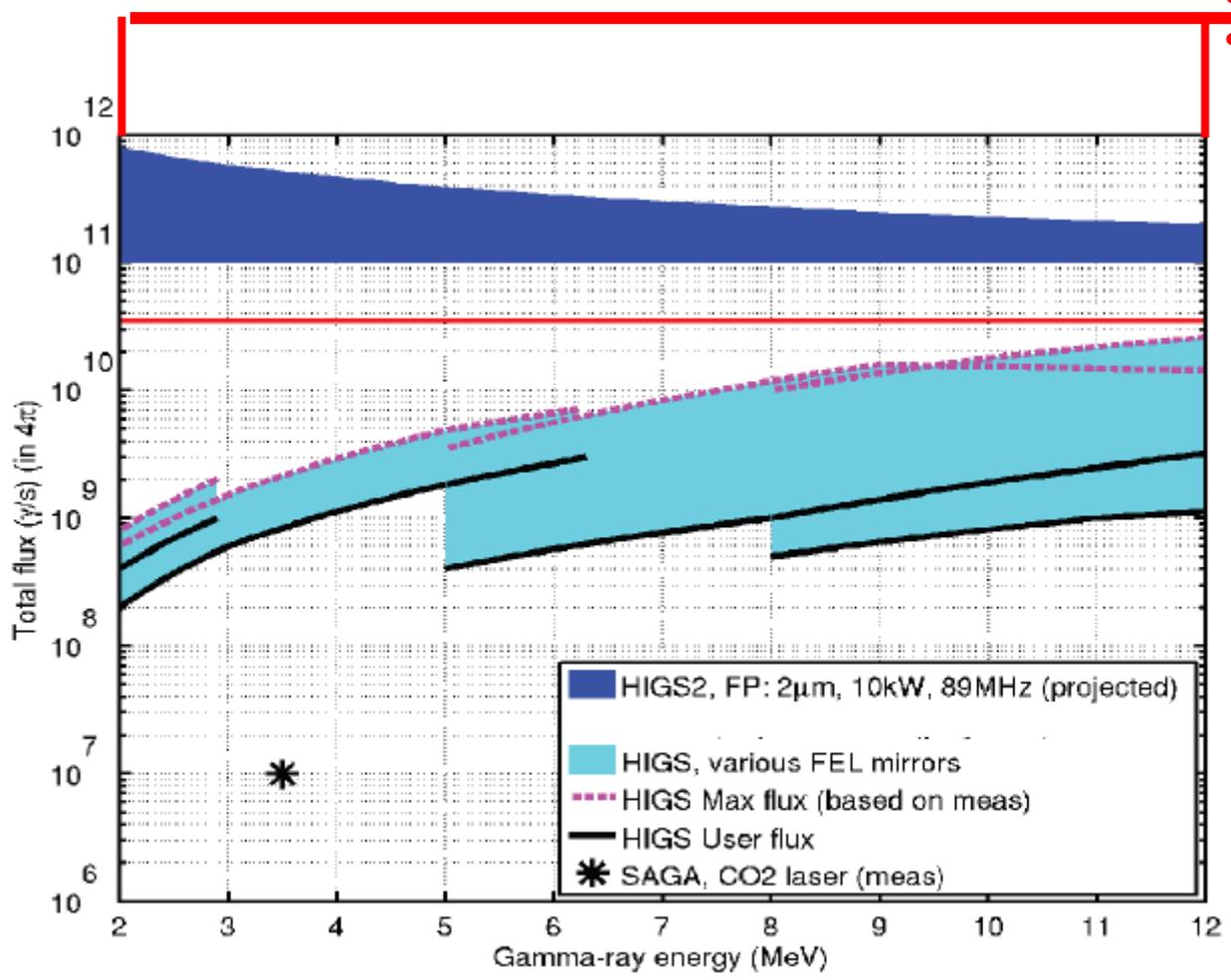
GAMMA BEAM PARAMETERS (for $\lambda=515\text{nm}$)

| | |
|-----------------------------------|---|
| Energy | 30 MeV |
| Spectral density | $9 \cdot 10^4$ ph/s/eV |
| Bandwidth | < 5% |
| Flux within FWHM bdw | $7 \cdot 10^{10}$ ph/s (total flux $9 \cdot 10^{12}$) |
| ph/e ⁻ within FWHM bdw | 10^{-6} |
| Peak Brilliance | $3 \cdot 10^{21}$ ph/s*mm ² *mrad ² 0.1%bdw |

Higs @ Duke Univ. World's most intense γ source



9×10^{12}
ERL facility
@ 30 MeV



Optical systems

LASER BEAM PARAMETERS

Wavelength 515 nm - 1030 nm

Average Power **300kW - 600 kW**

Pulse length **3 ps**

Pulse energy 7.5mJ - **15 mJ**

Spot size 30 um

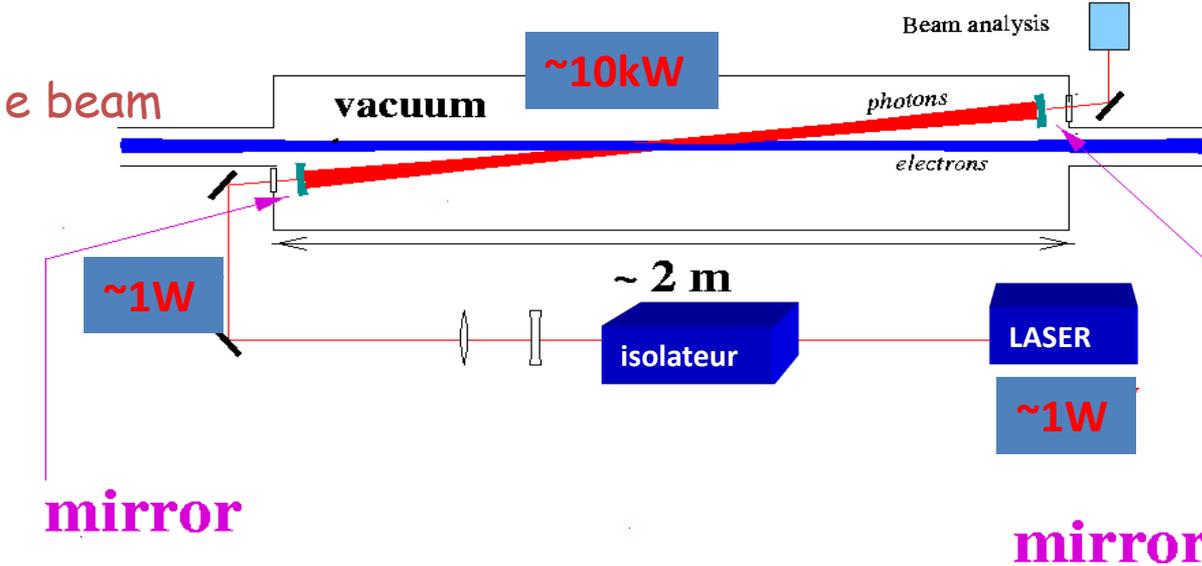
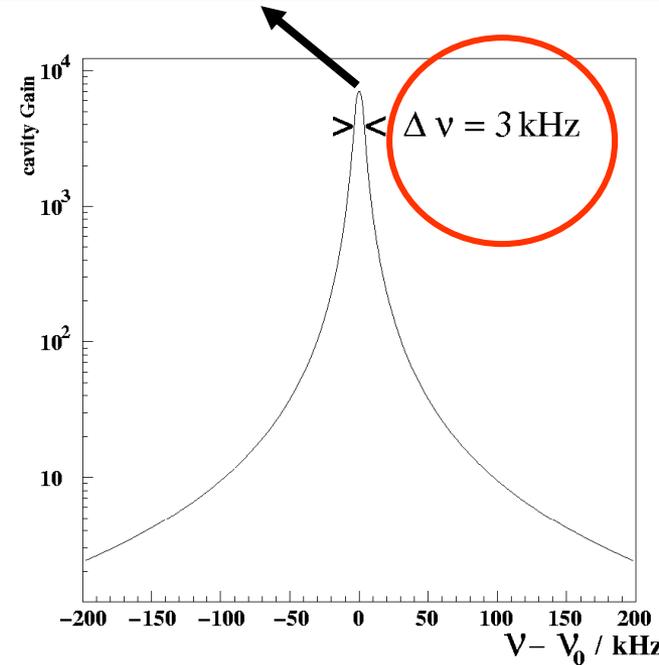
Bandwidth 0.02 %

Repetition Rate **40 MHz**

Optical resonator

Fabry-Perot cavity: Principle with continuous wave

$$\text{Gain} = 1/(1-R) \sim 10000$$



When $\nu_{\text{Laser}} \propto c/2L \Rightarrow$ résonance

• But: $\Delta\nu/\nu_{\text{Laser}} = 10^{-11} \Rightarrow$ STRONG & ROBUST laser/cavity
feedback needed

Pulsed laser/cavity feedback technique

Specificity → properties of passive mode locked laser beams

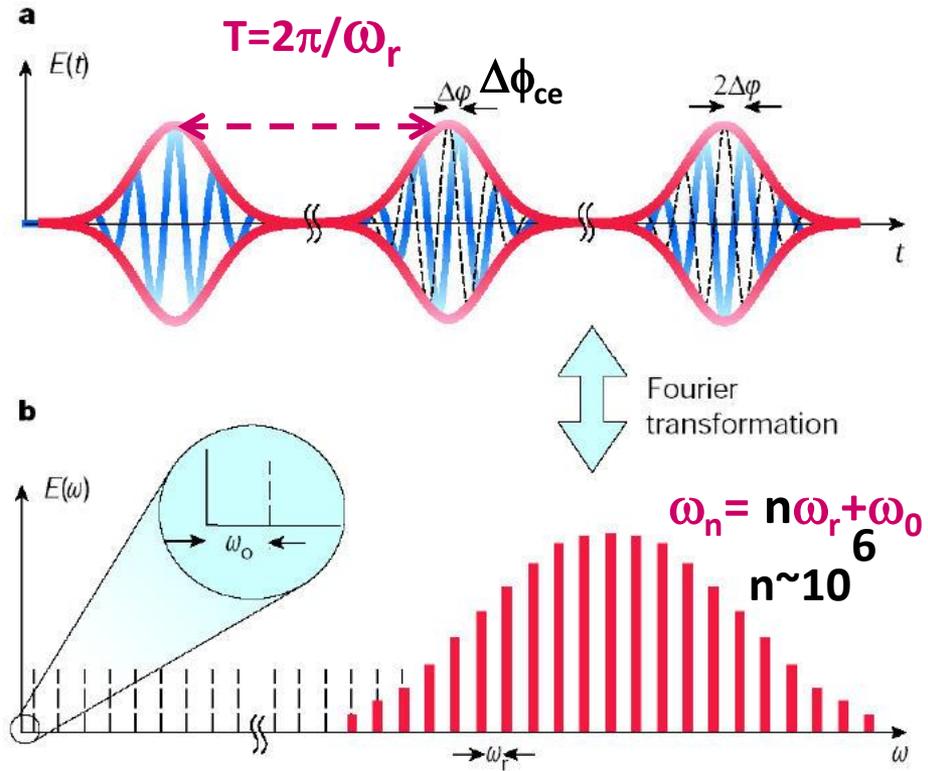
Frequency comb → all the comb must be locked to the cavity
 → Feedback with 2 degrees of freedom :

control of the Dilatation (rep. Rate)

&

Translation (CEP)

(well known metrological technics)



T. Udem et al. Nature 416 (2002) 233

Illustration of one issue : the laser cavity feedback

ERL Facility

Cavity finesse : $F \sim 10^4 \times \pi$
Optical path length : $L \sim 7.5\text{m}$

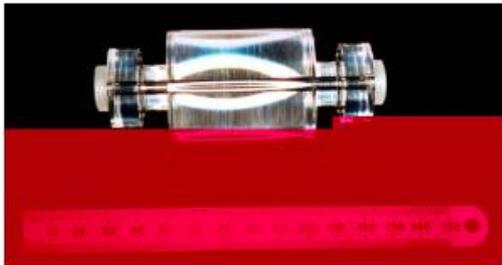
Cavity resonance
frequency linewidth
 $\Delta\nu = c/(LF) \sim 1.3\text{ kHz}!$

$\Delta\nu/\nu = \lambda/(LF) = \sim 10^{-12}$
Same numbers as in metrology !!!

• Ultra-Low Expansion
(ULE) Glass:



• Single-crystal
Sapphire
(cryogenic: $\sim 4\text{ K}$)



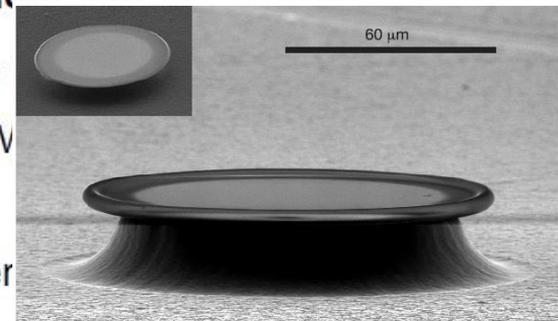
• Typical **length**: 10 cm
→ Free spectral range $\sim 1.5\text{ GHz}$

• Typical **finesse**: 300,000
→ linewidth $\sim 5\text{ kHz}$
→ power enhancement $\sim 10^5$

Linewidth 1.3kHz
→ $F = 10^6 \dots$

[applied power (CW):
intracavity power (CW)

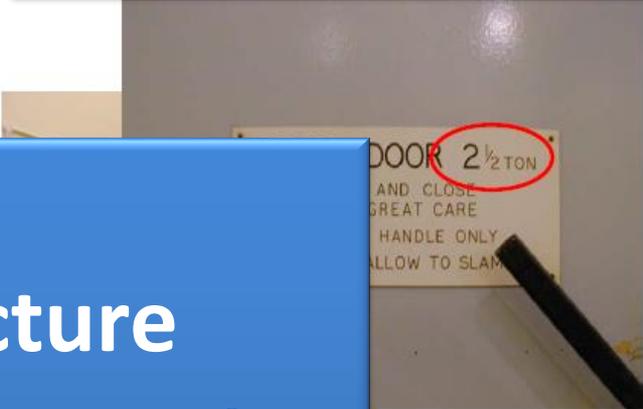
• Mirrors **optically
contacted** to spacer



Besides In metrology experiments :

The hyper stable small cavity is 'hyper' temperature stabilised

Into an hyper isolated room



For γ Compton machines

- ✓ 'Geant' mechanical structure
- ✓ Noisy accelerator environment
- ✓ Pulsed laser beam regime
- ✓ 1kHz linewidth oscillator
- ✓ 'Huge' average & peak power !

Put on an

ser is used,

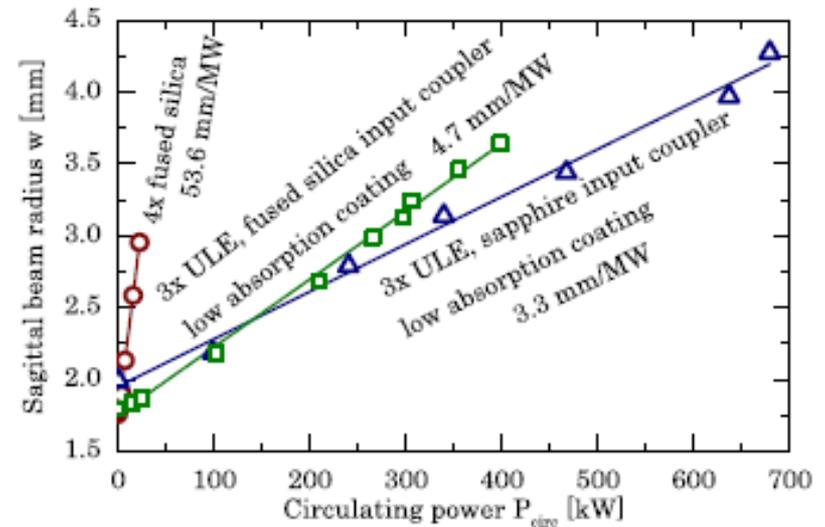
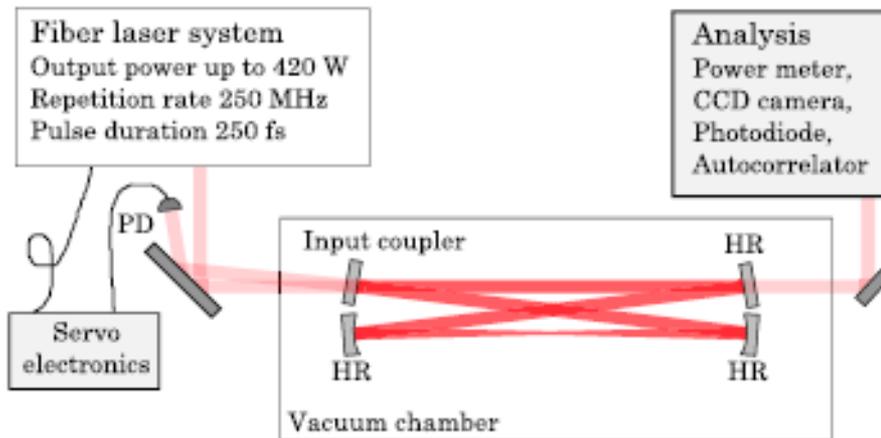
phisto

Stack power in pulsed regime

State of the art (Garching MPI):

~670kW, 10ps pulses, 1040nm @250MHz (F~5600)

OL39(2014)2595

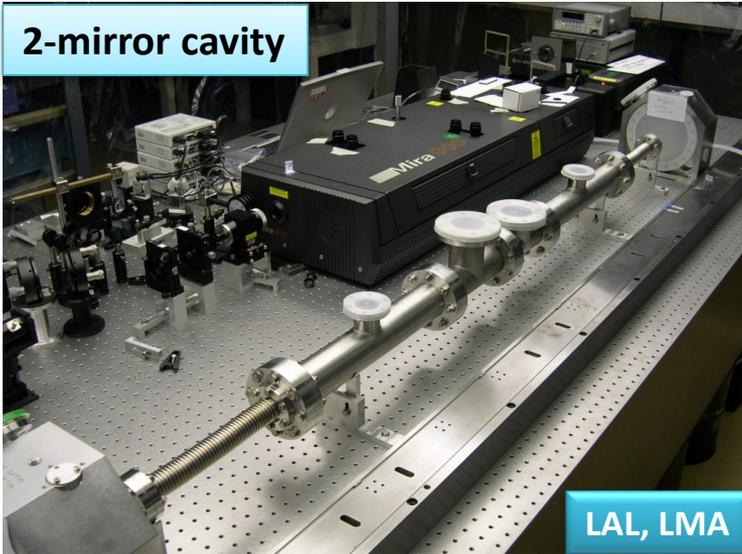


Issues

- control of thermal lensing and thermoelastic effects
- Damage threshold of mirror coatings

Highest cavity gain/finesse in pulsed regime

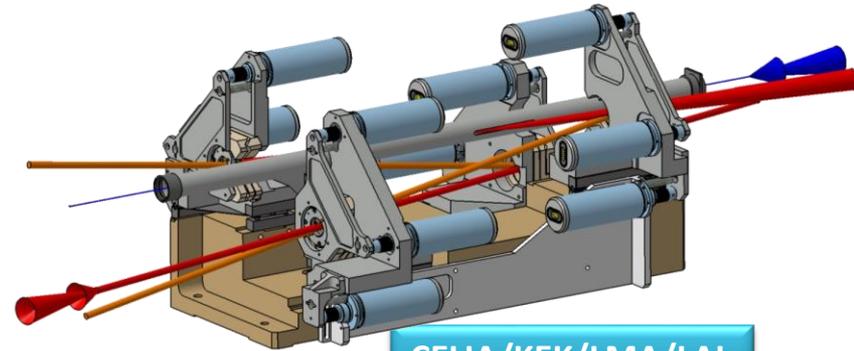
2-mirror cavity



LAL, LMA

- Ti:sapph oscillator
- Picosecond pulses @ $\sim 75\text{MHz}$
 - Stable lock, finesse ~ 30000
 - (\rightarrow BW feedback $\sim 100\text{kHz}$)

Non planar 4-mirror cavity

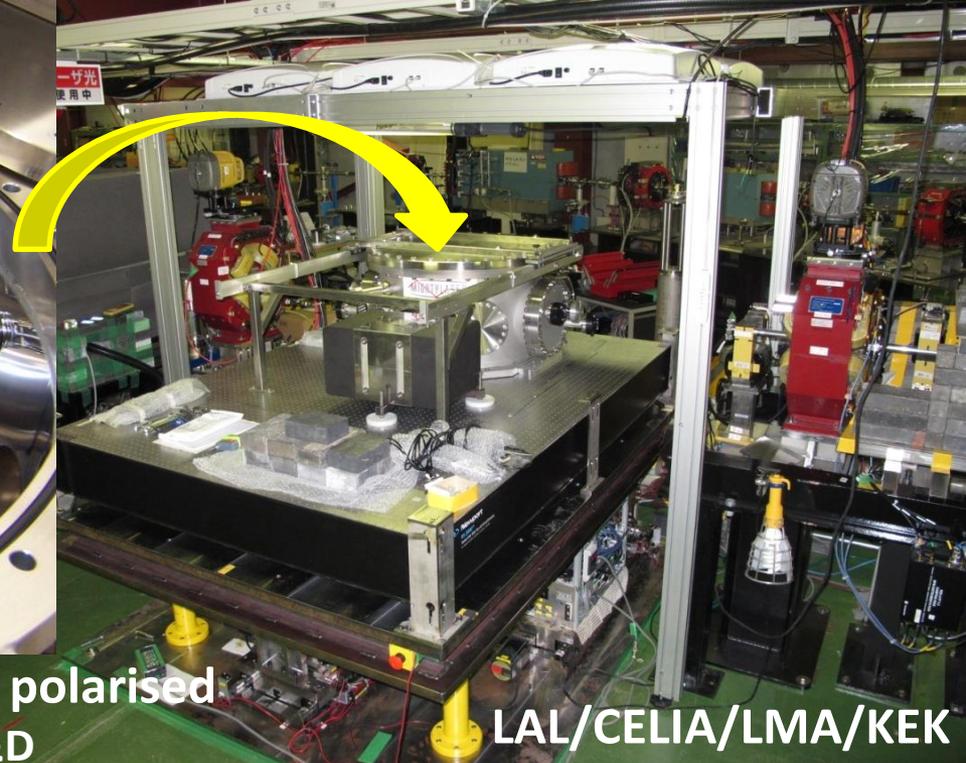


CELIA/KEK/LMA/LAL

- Yb fiber oscillator
- 100fs pulses @ $\sim 200\text{MHz}$
 - Stable lock, finesse ~ 30000
 - (\rightarrow BW feedback $\sim 10\text{MHz}$)
- Yb fiber system amplifier

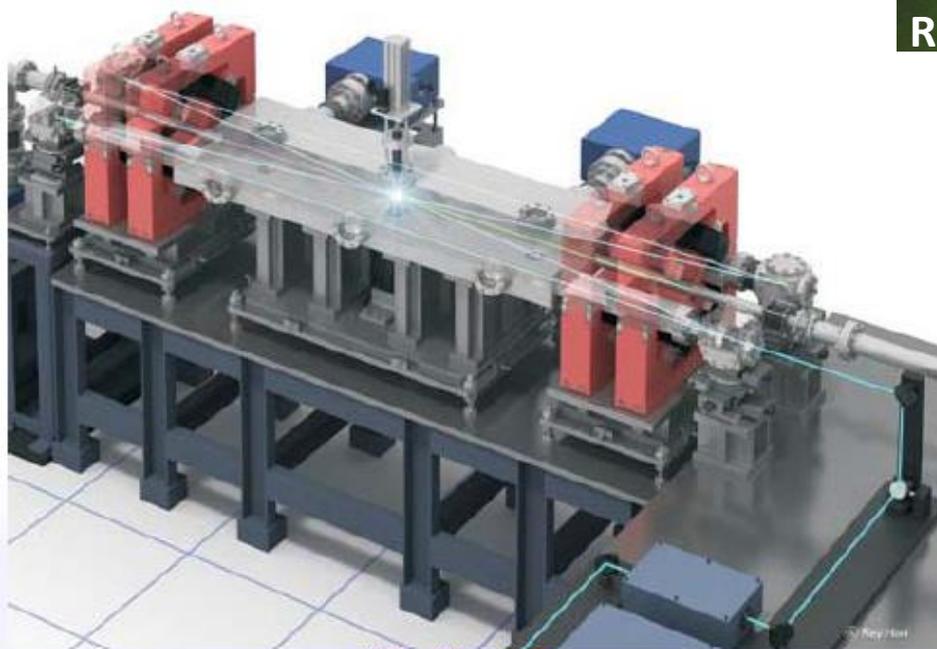
Installed /tested at ATF/KEK
(Compton e+ polarized source)

Some of the ATF/KEK 4-mirror cavities

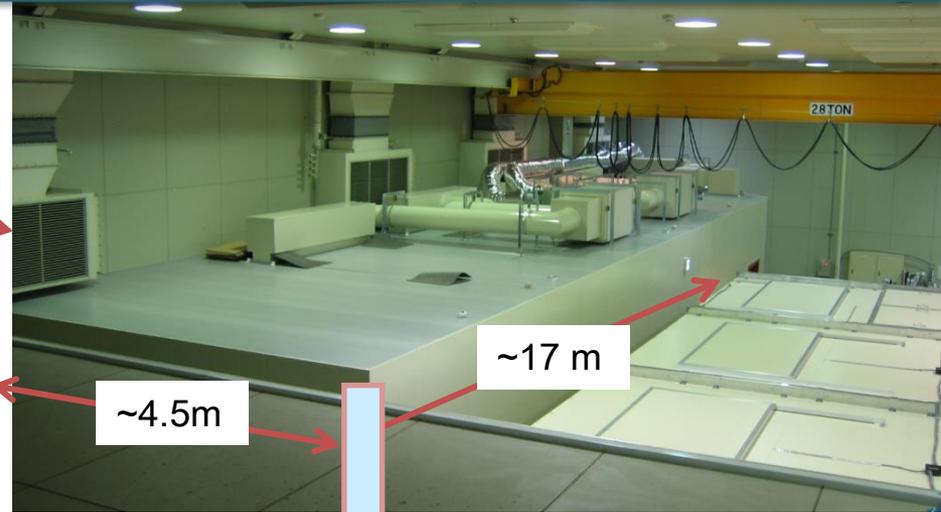
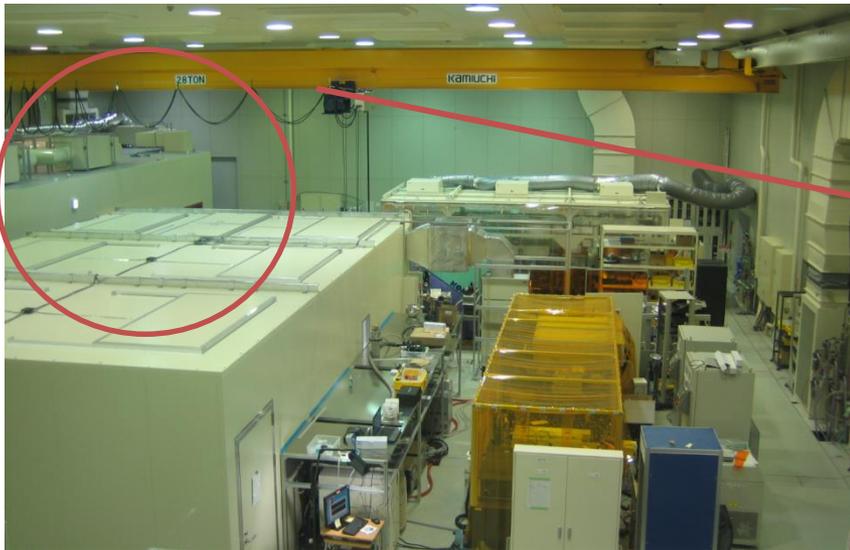


e+ polarised
R&D

LAL/CELIA/LMA/KEK

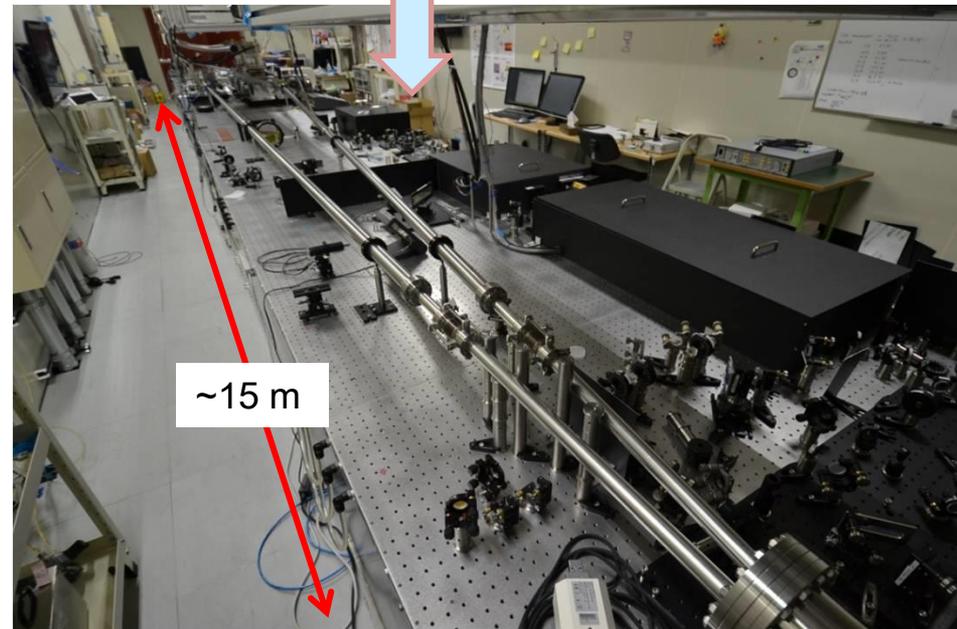
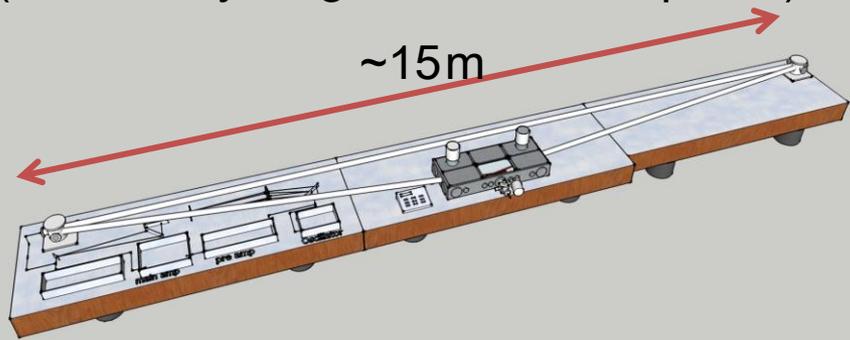


Very long monolithic cavity setup (Finesse~300) for harmonic generation



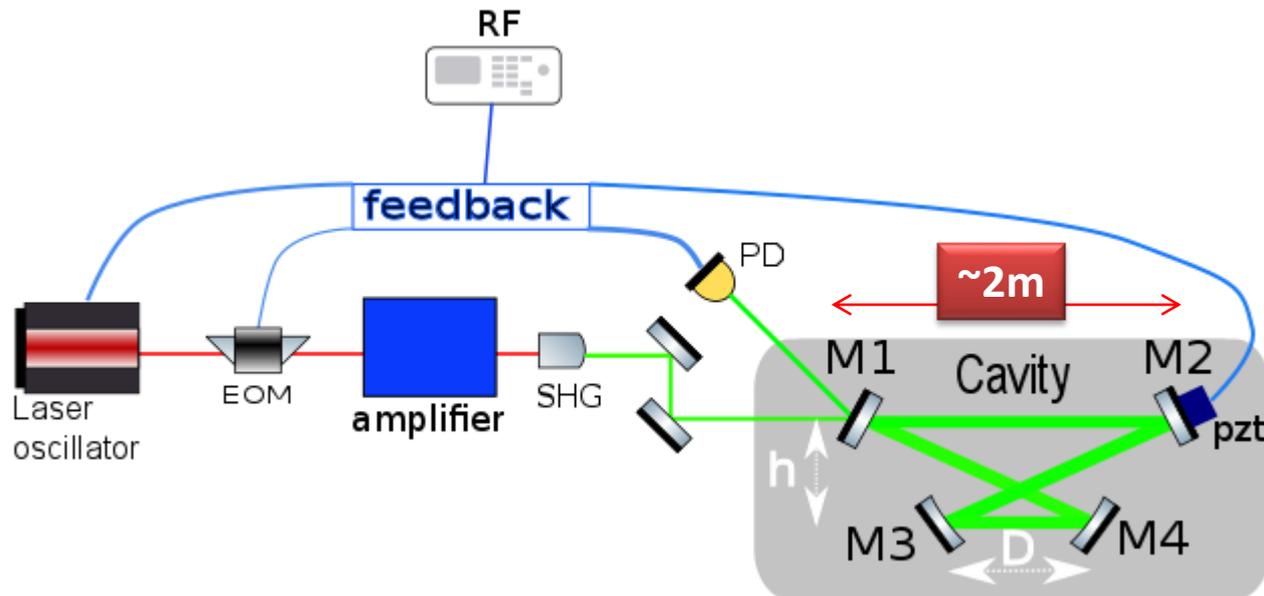
Vibration and sound isolation for external cavity

4-mirrors **bow-tie** cavity
(30m cavity length → 10MHz rep rate)

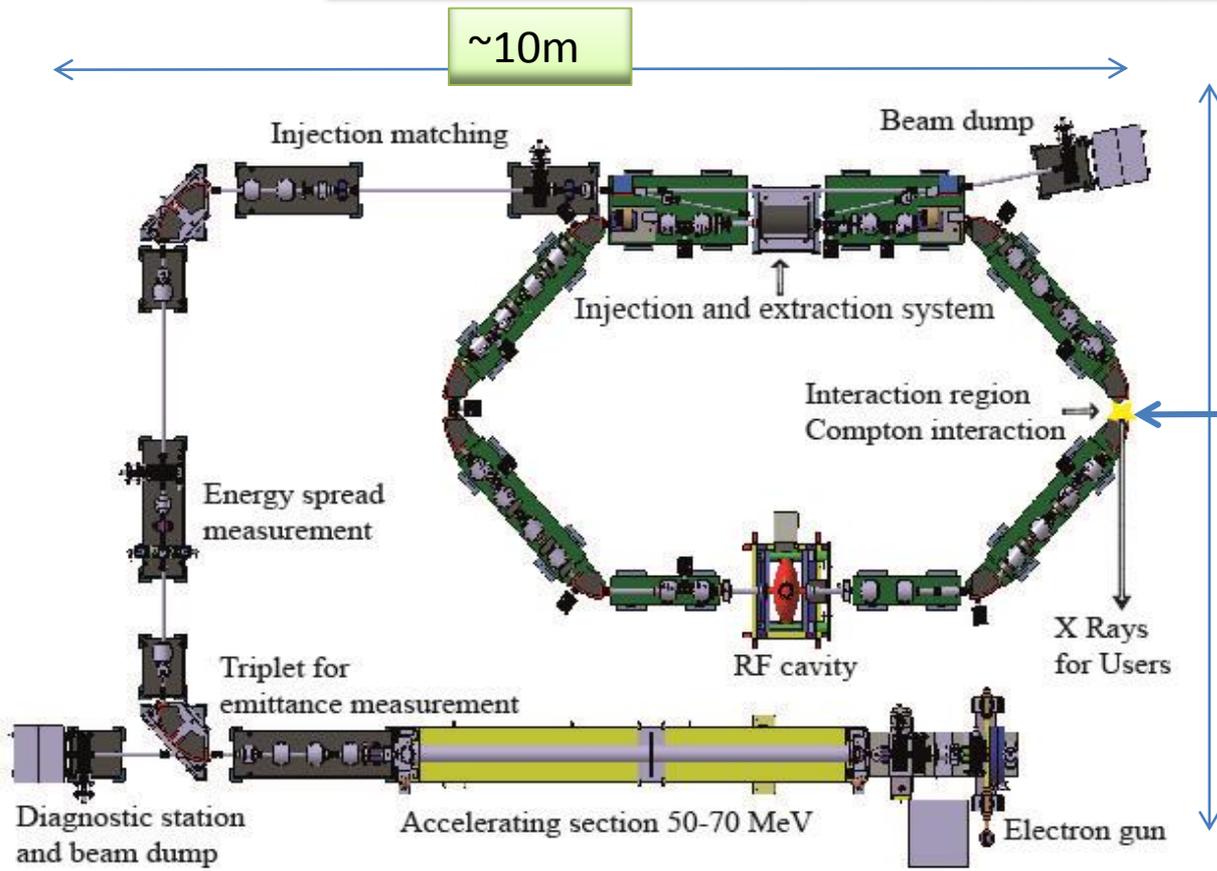


Cavity for the ERL Facility

- 4-mirror cavity of 7.5 m round-trip length
 - 1 inch mirror diameter
 - HR coatings
- 40 MHz Yb doped oscillator and fiber amplifier



Compact X ray source ThomX machine Under construction at Orsay



Optical resonator 37MHz

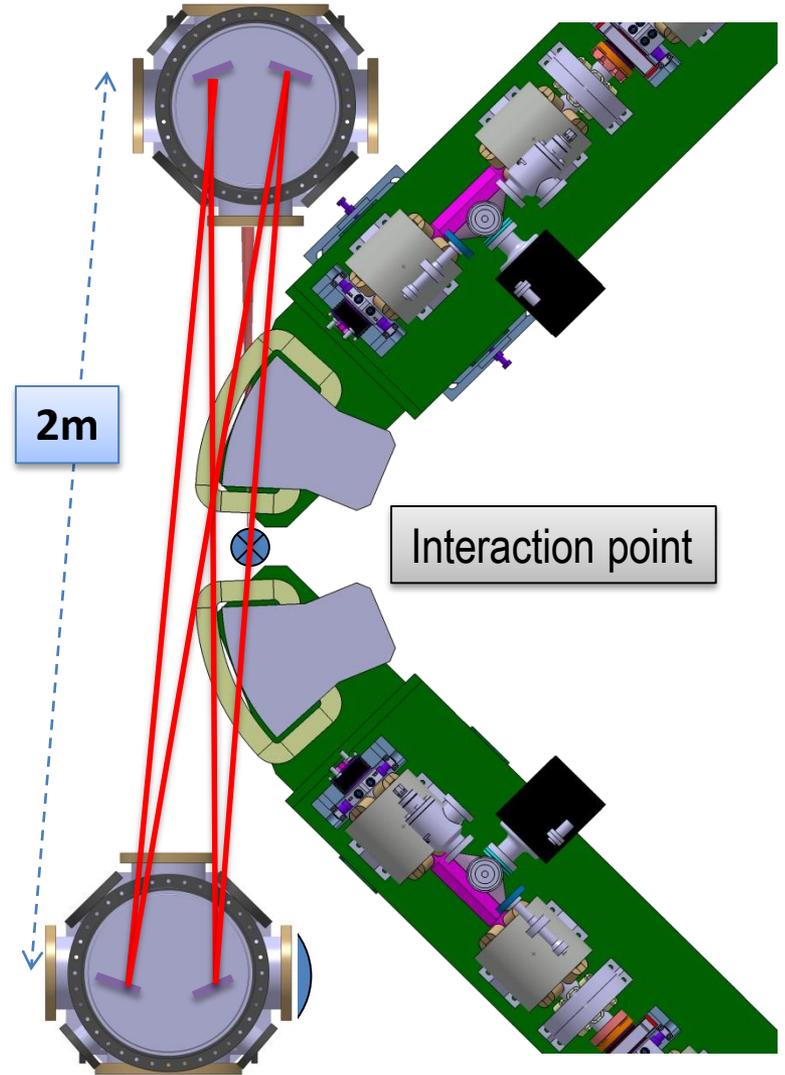
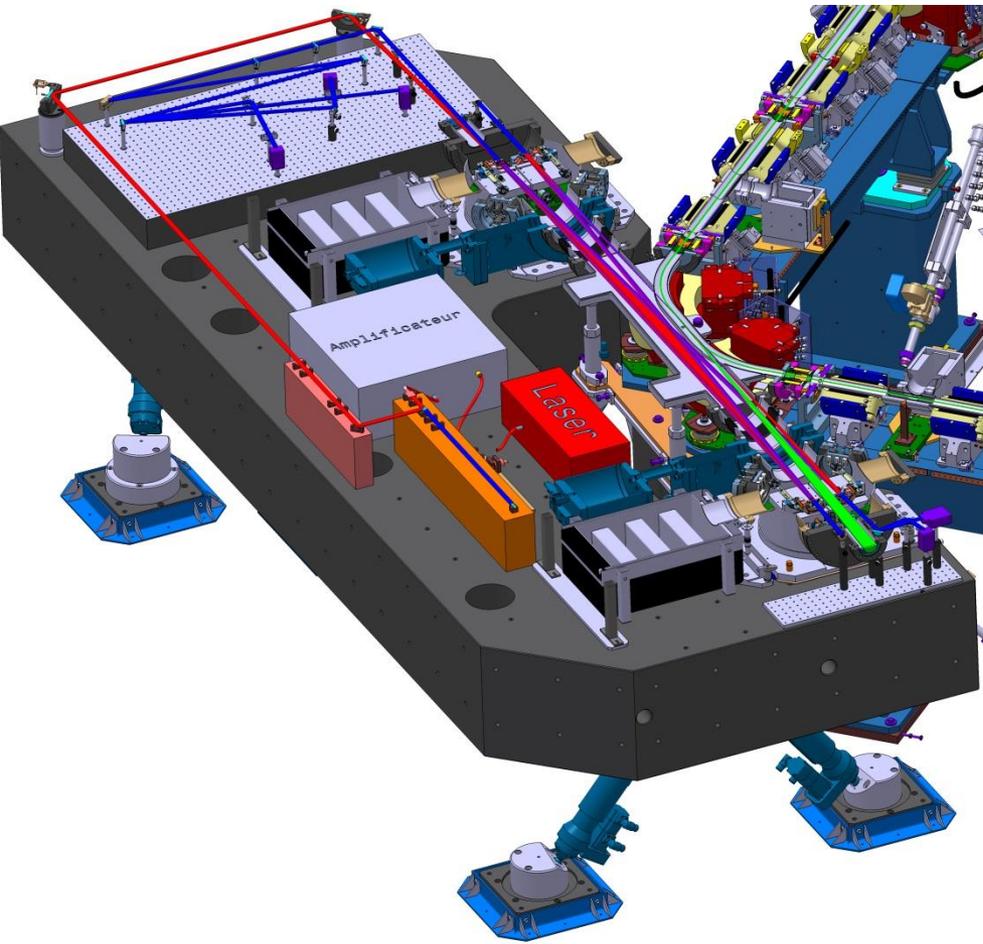
✓ GOAL:

- ✓ 10-20ps
- ✓ >150W incident power
- ✓ Cavity finesse ~30000
- ➔ goal : 1MW average power

ThomX

Mechanical stability

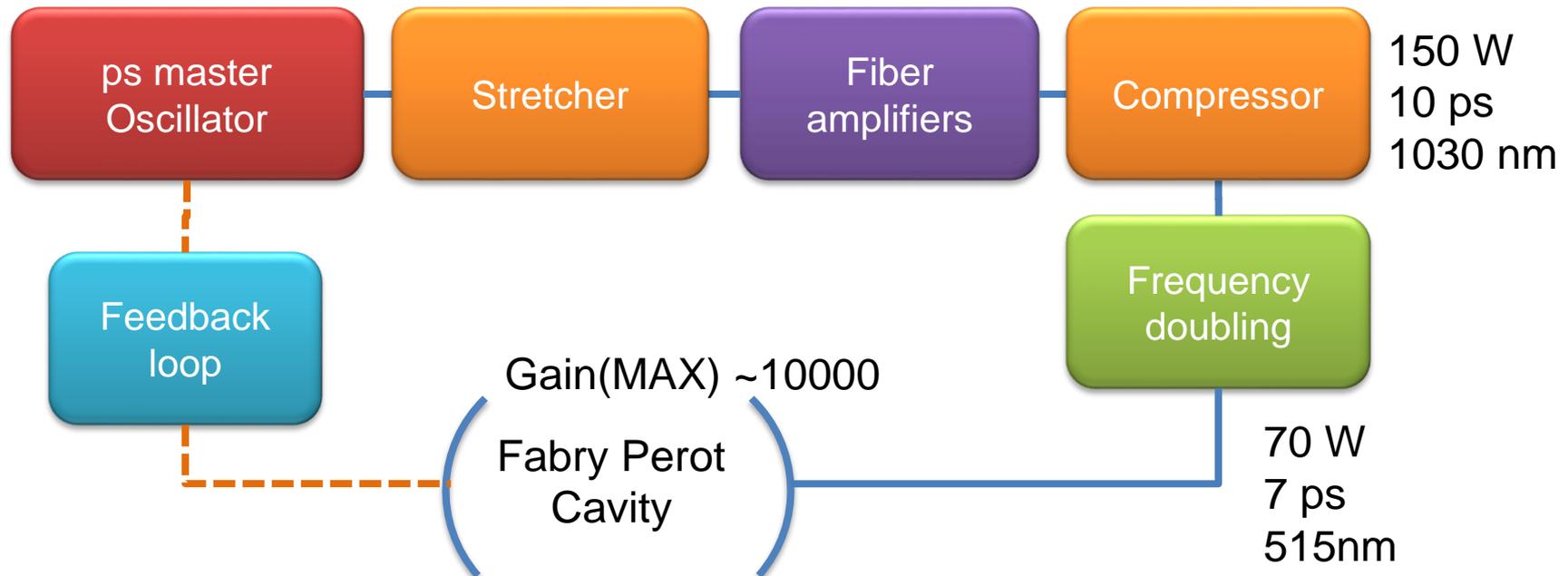
- 4-mirror cavity
- 8 m round-trip



Input laser beam: Configuration 1

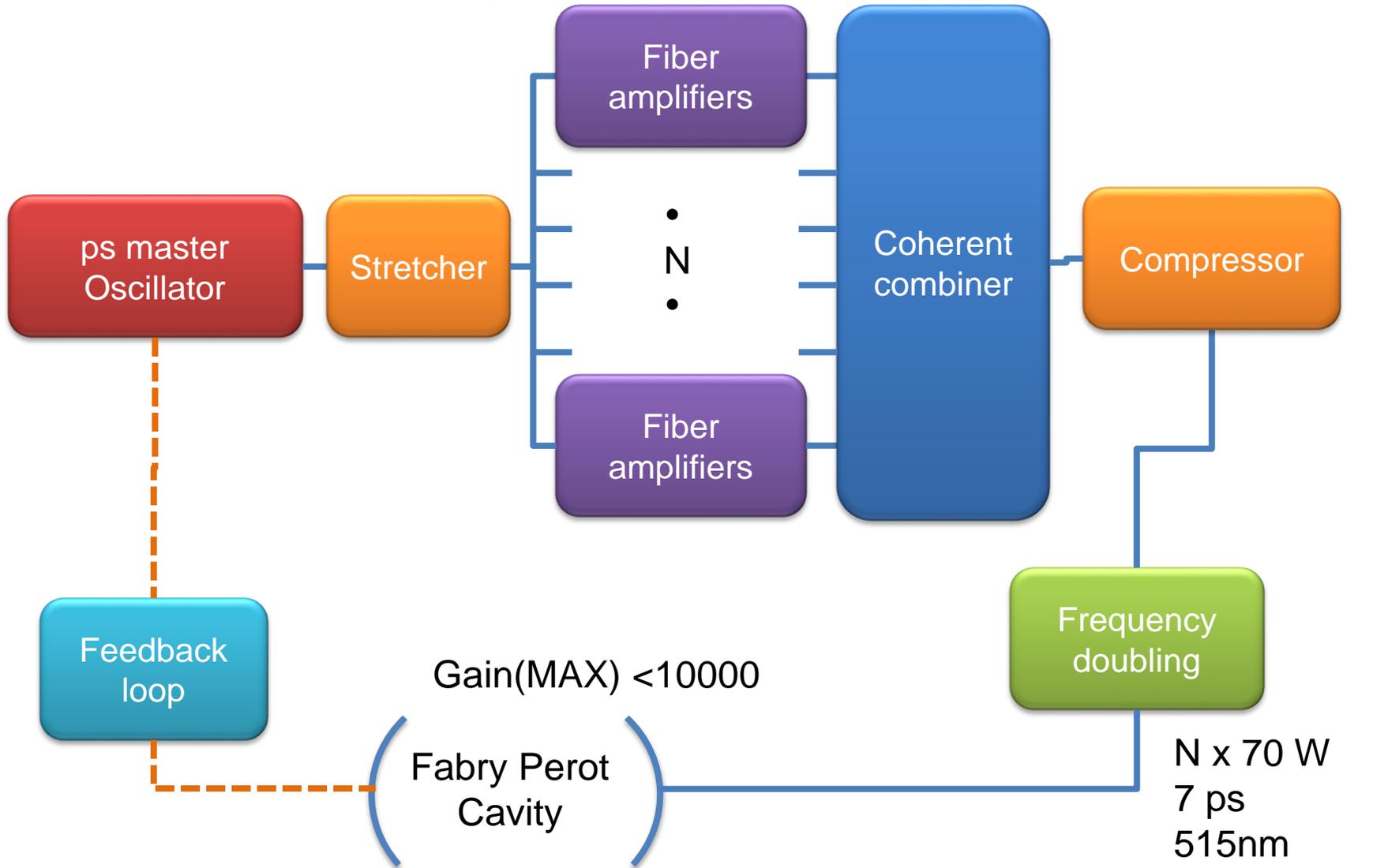
'higher' finesse / 'lower' input power

Configuration for LHeC ERL gamma source :
~same as ThomX project (CELIA, LAL)
R&D going on at LAL and CELIA Labs.



Input laser beam: Configuration 2

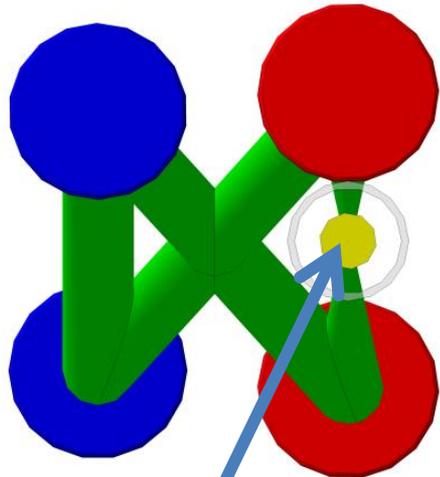
'Lower' finesse / 'higher' input power



2 plane mirrors

2 concave mirrors

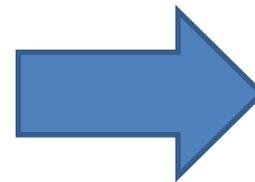
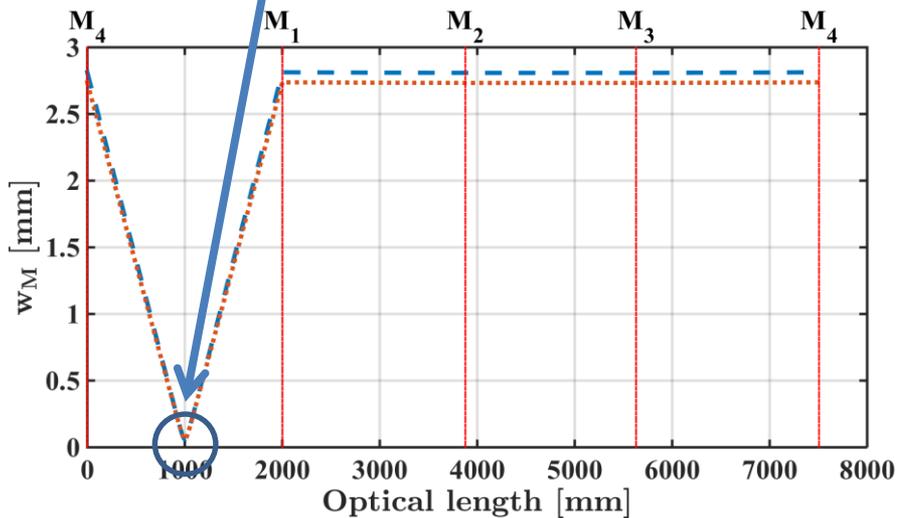
Possible implementation



Incident laser

Gamma beam

Intensity spot size $30 \mu\text{m}$



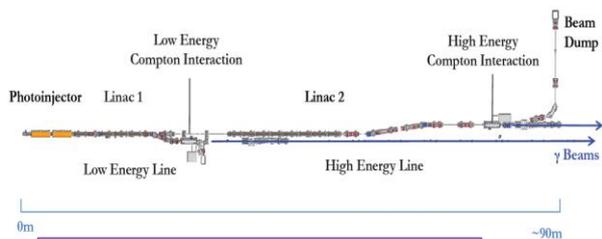
Room For optimization

Summary

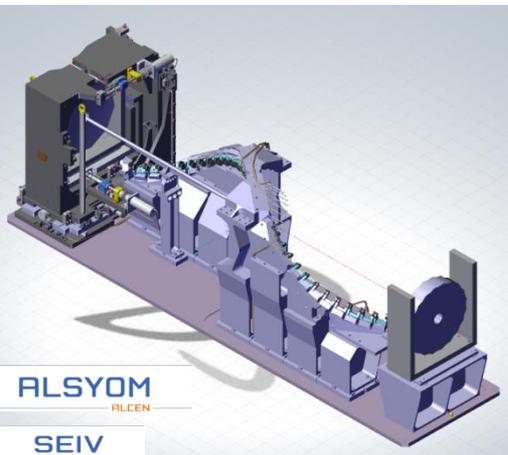
- LHeC ERL offers the opportunity to provide gamma ray facility
 - Very high flux expected (at least 2 orders of magnitude above expected upgrades of existing facilities)
 - Spectral density above existing facilities
- Fabry-Perot cavities are suitable to produce this high gamma ray flux
 - 670kW average power demonstrated (@1040nm...)
 - Technology tested on accelerators (e.g. ATF/KEK)
 - Various projects are under-way to push the technology at its limits (→1MW stacked power)
- High average power Yb doped fiber mature technology & related techniques mitigate the risks
 - Higher/lower cavity finesse % lower/higher input laser average power

Low frequency e-bunch trains (\square 100Hz) & low nb bunch/train

e.g. ELI-NP γ ray

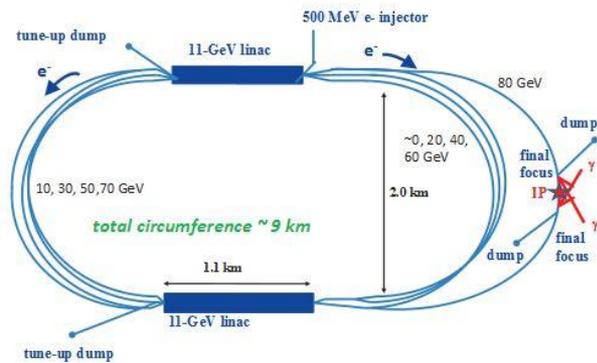


- 'reasonable' laser average power
- 'Large' peak power
- ➔ laser pulse recirculator



'Low' frequency cw e-beam (<1MHz)

e.g. $\gamma\gamma$ colliders
arXiv:1208.2827



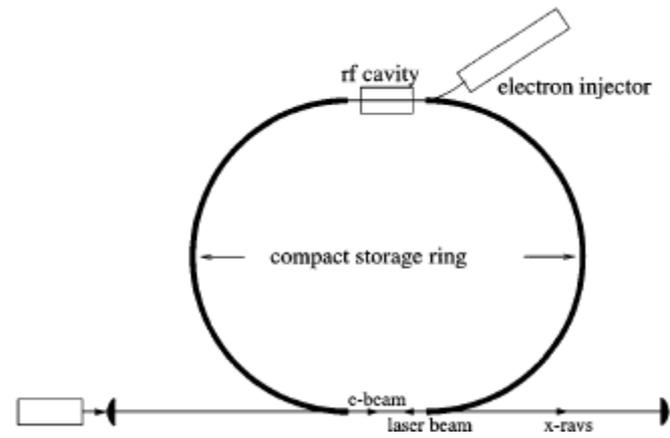
- Large average power 1MW
- Large peak power 1 TW

<http://www.izest.polytechnique.edu>



High frequency cw e-beam (\square 10MHz)

e.g. compact X ray Compton machines
Huang&Ruth PRL80(1998)977
(Lyncean Co.)



- Large average power
- 'reasonable' peak power
- ➔ Fabry-Perot cavity

